

Attorney Docket No. 5308-279

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Sei-Hyung Ryu
Serial No.: 10/698,170
Filed: October 30, 2003

Confirmation No. 2502
Group Art Unit: 2811
Examiner: Tran, Long K.

For: **VERTICAL JFET LIMITED SILICON CARBIDE POWER METAL-OXIDE
SEMICONDUCTOR FIELD EFFECT TRANSISTORS AND METHODS OF
FABRICATING VERTICAL JFET SILICON CARBIDE METAL-OXIDE
SEMICONDUCTOR FIELD EFFECT TRANSISTORS**

Date: March 14, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Sir:

Attached is a list of documents on Form PTO-1449, together with a copy of any listed foreign patent document and/or non-patent literature. Copies of the listed U.S. patents and U.S. patent application publications are not provided herewith in accordance with the amendment by the U.S. Patent and Trademark Office to 37 C.F.R. § 1.98(a)(2)(ii) effective October 21, 2004.

It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. § 1.56 and Section 609 of the MPEP. No fee is believed due. However, the Commissioner is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-0220.

Respectfully submitted,

Elizabeth A. Stanek
Registration No. 48,568

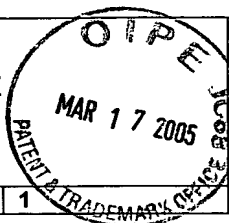
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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 14, 2005.

Erin A. Campion

Substitute form 1449A/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	10/698,170
		Filing Date	October 30, 2003
		First Named Inventor	Sei-Hyung Ryu
		Group Art Unit	2811
		Examiner Name	Tran, Long K.
Sheet 1 of 1	Attorney Docket Number	5308-279	



U.S. PATENTS AND PATENT PUBLICATIONS					
Examiner Initials*	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code (if known)		
	1.	US-6,759,684		Fukuda et al.	07-06-2004
	2.	US-6,653,659		Ryu et al.	11-25-2003
	3.	US-6,573,534		Kumar et al.	06-03-2003
	4.	US-6,551,865		Kumar et al.	04-22-2003
	5.	US-6,448,160		Chang et al.	09-10-2002
	6.	US-6,420,225		Chang et al.	07-16-2002
	7.	US-6,399,996		Chang et al.	06-04-2002
	8.	US-6,180,958		Cooper, Jr.	01-30-2001
	9.	US-5,629,531		Palmour	05-13-1997
	10.	US-5,396,085		Baliga	03-07-1995
	11.	US-5,385,855		Brown et al.	01-31-1995
	12.	US-5,270,554		Palmour	12-14-1993
	13.	US-5,111,253		Korman et al.	05-05-1992
	14.	US-4,811,065		Cogan	03-07-1989
	15.	US-2004/0211980	A1	Ryu	10-28-2004
	16.	US-2004/0212011	A1	Ryu	10-28-2004
	17.	US-2002/0047125	A1	Fukuda et al.	04-25-2002

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Office	Number	Kind Code (if known)		
	18.	EPO	EP 1 204 145	A2	Matsushita Electric Industrial Co., Ltd.	05-08-2002
	19.	PCT	WO 98/02916		ABB Research, Ltd.	01-22-1998

OTHER NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T
	20.	United States Patent Application Serial No. 10/686,795, "Methods of Forming Power Semiconductor Devices Using Boule-Grown Silicon Carbide Drift Layers and Power Semiconductor Devices Formed Thereby," filed October 16, 2003 (Attorney Docket No. 5308-286).	

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.